

AKERMAN SENTERFITT

ATTORNEYS AT LAW

222 LAKEVIEW AVENUE, SUITE 400
 POST OFFICE BOX 3188
 WEST PALM BEACH, FLORIDA 33402-3188
 PHONE (561) 653-5000 • FAX (561) 653-5333
<http://www.akerman.com>

JO Rec'd PCT/PTO 05 APR 2002

FAX: 1-703-308-7751

PLEASE DELIVER THE ACCOMPANYING TELECOPIED MATERIAL TO:	TRANSMITTAL DATE: Apr 5, 2002
NAME: Customer Corrections	CLIENT/MATTER NO: 2000-22
PHONE:	TOTAL PAGES: 2
FIRM/COMPANY NAME: U.S. Patent and Trademark Office	CITY, STATE: Washington, DC

RECEIVED

MAY 06 2002

SENDER'S NAME: Kendra Quinn

Technology Center 2800

Comments from Sender: Re: Applicant: MAJIMA et al.; Serial No. 09/890,550

Attached please find a copy of an Official Filing Receipt. Please correct the filing receipt to reflect the following:

The Title of the invention should read "Porous Silicon Carbide Sinter and Silicon Carbide-Metal Composite that are Optimal for a Wafer Grinder Table"

Please forward a corrected filing receipt to this office at your earliest convenience. Thank you for your assistance in this matter.

PLEASE CALL (561) 653 5000 IMMEDIATELY
 IF ANY PAGES ARE NOT RECEIVED OR RECEIVED IN ERROR.

☒ ORIGINAL WILL NOT FOLLOW

☐ ORIGINAL WILL FOLLOW by

☐ Regular Mail

☐ Registered or Certified Mail

☐ Overnight Delivery

☐ Hand Delivery

☐ Other

TECHNOLOGY CENTER 2800

MAY - 7 2002

RECEIVED

THE INFORMATION CONTAINED IN THIS TRANSMISSION IS PRIVILEGED AND CONFIDENTIAL INFORMATION INTENDED ONLY FOR USE OF THE INDIVIDUAL OR ENTITY NAMED ABOVE. IF THE READER OF THIS MESSAGE IS NOT THE INTENDED RECIPIENT, YOU ARE HEREBY NOTIFIED THAT ANY DISSEMINATION, DISTRIBUTION OR COPY OF THIS COMMUNICATION IS STRICTLY PROHIBITED. IF YOU HAVE RECEIVED THIS COMMUNICATION IN ERROR, PLEASE IMMEDIATELY NOTIFY US BY TELEPHONE AND RETURN THE ORIGINAL MESSAGE TO US AT THE ABOVE ADDRESS TO THE ATTENTION OF THE SENDER VIA THE U.S. POSTAL SERVICE OR AS OTHERWISE DIRECTED BY TELEPHONE. THANK YOU.



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/890,550	01/14/2002	2812	1436	2000-22	6	27	7

CONFIRMATION NO. 4691

REPLACEMENT FILING RECEIPT



CC000000007721557

J Rodman Steele Jr
Akerman Senterfitt & Eidson
Post Office PO Box 3188
West Palm Beach, FL 33402-3188

Date Mailed: 03/26/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Kazutaka Majima, Gifu, JAPAN;
Hiroyuki Yasuda, Gifu, JAPAN;

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP00/08284 11/24/2000

Foreign Applications

JAPAN 11-340408 11/30/1999
JAPAN 11-340409 11/30/1999
JAPAN 2000-126085 04/26/2000

Projected Publication Date: Not Applicable, filed prior to November 29, 2000

Non-Publication Request: No

Early Publication Request: No

Title

Porous silicon carbide sintered compact and silicon carbide metal composite suitable for use in
table for wafer polishing machine

Preliminary Class